

DOCKET: CU-3495

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

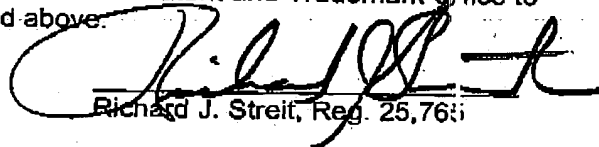
In re Application: Sang Tae AHN et al.]	GRP ART UNIT:
Serial No: 10/738,399]	Ex.:
Filed: December 17, 2003]	

For: METHOD FOR FABRICATING ISOLATION LAYER IN SEMICONDUCTOR
DEVICE**Certification under 37 C.F.R. §1.8(a)**

The USPTO Central Fax No. (703) 872-9306

Date of Fax Transmittal: May 21, 2004


I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.


Richard J. Streit, Reg. 25,765The Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**APPOINTMENT OF ASSOCIATE ATTORNEY**

Dear Sir:

The undersigned Attorney for Applicants in the above identified application for Letters Patent, hereby appoints **Woochoon William Park, Reg. No. 55,523** as my Associate Attorney, to prosecute this application, to make alterations and amendments therein, to receive the patent, and to transact all business in the United States Patent & Trademark Office connected therewith.

Please address and send all correspondence to:

Richard J. Streit
Ladas & Parry
224 South Michigan Avenue
Chicago, Illinois 60604
Customer No. 26530Dated: May 21, 2004
Richard J. Streit, Reg. 25,765
Ladas & Parry
224 South Michigan Avenue
Chicago, Illinois 60604
(312) 427-1300